Applications are invited for the post of a Junior Research Fellow in a DST-International Bilateral Cooperation Division for Indo-Russian grant award project entitled **"Regeneration mechanisms of deep-layer skin wounds in response to treatment with polyelectrolyte-hydrogel complex dressing and gene therapy "** to be executed in the Department of Biomedical Engineering, National Institute of Technology, Raipur.

ELIGIBILITY

Educational Qualification : One year experience with M.E/ M.Tech in Biomedical Engineering, Bioengineering, Biotechnology, MMST, Medical Electronics, Biomedical Instrumentation, Biochemical Engineering, BioPhysics, Mechanical Engineering, Polymer Science Engineering, Material Science Engineering, Metallurgical Engineering or equivalent discipline

Fellowship Amount   :   Rs.28,000 +20% HRA p.m

Duration of the project :   2 years

Applications completed in all respects should reach the undersigned by 18-03-2019 and applicants should appear for the interview on 19-03-2019 at 11:00 AM in the Department of Biomedical Engineering, National Institute of Technology, Raipur. In case of any queries, contact the PI at **9098033297 / 9399603267**, or email at **arinbit.bme@nitrr.ac.in**.

Dr. Arindam Bit
Principal Investigator
Assistant Professor
Biomedical Engineering Department
NIT Raipur
Chattishgarh-492010

DST-International Bilateral Cooperation Division for Indo-Russian grant award project entitled

"Regeneration mechanisms of deep-layer skin wounds in response to treatment with polyelectrolyte-hydrogel complex dressing and gene therapy"

Application for Senior Research Fellow

1. Name   _____ _____

                        (Surname)   (First Name)

2. Address

                Phone: Fax No.:   Email ID:

3. Date of Birth   :
4. Nationality   :
5. Sex   :
6. Complete Academic Record (Starting from X standard)

Degree and Specialization	University/Institute	Year of Completion	Division

7. Areas of Interest

8. Publications/conference participation (National/International)

9. Research experience apart from M.Tech research

9. Any Other Relevant Information

Signature of Applicant

Date   :

Place   :

Note: Attach a Xerox copy of the relevant documents with the application